## BEST AVAILABLE COPY

U.S. UTILITY Patent pplication

PATENT NUMBER and ISSUE DATE

ALBORETH LINKS

<b>APPL NUM</b> 10060366	92/01/2002	CLASS 451	SUBCLASS 5	<b>GAU</b> 3723	EXAMINER Mc Donald
*APPLICANT	S: Kimura	Norio; Ist	nii You; Nishi T	oyomi;	Kawamoto Takayoshi; Sakurai
Γakeshi;					
	•				
	3 DATA VERIFIED				
'HIS APPLICA	TION IS A DIV OF	08/881,6	316 06/25/1997	7	
	LM				
					.*
	PPLICATIONS VE /1996 06/25/1996	RIFIED:			
AFAN 104012	5vM				
G-PUB DO N	OT PUBLISH 🗖		RESCIN		
reign priority clain USC 119 condition		yes			ATTORNEY DOCKET NO
	rledged Examiners's int	ials (	300		2002-0064
LE : Method	and apparatus for	dressing	polishing cloth		
		. ,,			U.S.DEPT. OF COMM./PAT.& TM-PTO-436L(Rev. 12-9)
		,,			
retrained to					

NOTICE OF ALLOWANCE MAILED  ISSUE FEE			CLAIMS ALLOWED				
		Assistant Examiner	Total Claims		Print Claim for O.G		
			DRAWING				
Amount Due	Date Paid		Sheets Drwg.	Figs.Drwg.	Print Fig.		
TERMINAL DISCLAMER		Primary Examiner	Applicati n Examiner				
		PREPARED F R ISSUE					
		WARNING: The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368, Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.					
		FILED WITH: DISK	(CRF) (Attached i	n pocket on rigi	CD-ROM nt inside flap)		